

IFW #

Docket No.: 2336-241

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Je Won KIM *et al.* : Confirmation No.2636
U.S. Patent Application No. 10/776,228 : Group Art Unit: 2812
Filed: February 12, 2004 : Examiner: SAVITRI MULPURI
For: METHOD OF MANUFACTURING NITRIDE SEMICONDUCTOR LIGHT
EMITTING DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection or Notice of Allowance, but before payment of the Issue Fee.

CERTIFICATION PARAGRAPH

The undersigned hereby certifies that each item of information contained in this

information disclosure statement was first cited in any communication from a foreign patent

12/06/2005 SZEWDIE1 00000184 10776228

01 FC:1806

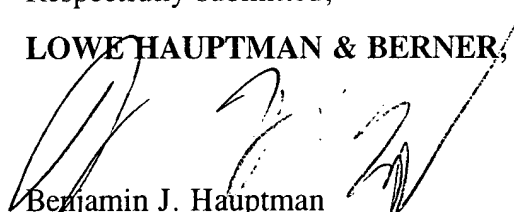
180.00 0P

office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement (37 CFR 1.97 (e)(1)). A copy of the Official Action forwarded in the corresponding Korean application is attached for the Examiner's information.

A credit card authorization form in the amount of \$180.00 is attached. Any deficiency or overpayment should be charged or credited to Deposit Account No. 07-1337.

Respectfully submitted,

LOWE HAUTMAN & BERNER, LLP



Benjamin J. Hauptman
Registration No. 29,310

1700 Diagonal Road, Suite 310
Alexandria, Virginia 22314
(703) 684-1111 BJH/klb
Facsimile: (703) 518-5499
Date: December 5, 2005

**INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION****(PTO-1449)**ATTY. DOCKET NO.
2336-241U.S. PATENT
APPLICATION NO.
10/776,228APPLICANT
Je Won KIM *et al.*FILING DATE
February 12, 2004GROUP
2812**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	Patent Abstracts of Japan - Publication No. 2001-200366, Published July 24, 2001
EXAMINER	DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.